

CLEAN ROOM OF INTEGRATED MICRO AND NANOFABRICATION

“Qualification 0.1” Application Form

Mr/Ms
With ID/Passport

- Asks for “Qualification 0.1” that enables you to access to the IMB-CNM (CSIC) Micro&Nanofabrication Clean Room with the object of:

- Admits that has read, understood and assimilated the document entitled “Protocol 0.1 of Access to Integrated Micro&Nanofabrication Clean Room (CSIC ICTS)”, and accepts the compromise of accomplishing the rules stated in the document.

In addition you are committed to read and assimilate corrections, additions, or reissued versions, on documents produced in the future and follow the stablished rules and procedures. In particular accepts to attend meetings and courses of information concerning behaviour inside the Clean Room, whenever requested to do so.

WORK ADDRESS

Centre/Department:

Street :

Postcode , City , Country:

Telephone number:

e-mail:

Declares that financial charges arising from this access shall be assumed by (Project, Department, Center):

Bellaterra, on

of 201_

To be approved by the Responsible
to assume economical charges.

Applicant Signature _____